

**Remote participation – hardware at KEK –
N.Terunuma and comments on experience from
participants – M.Wendt, M.Woodley, et al (via Webex)**

Tuesday, 27 May 2008 13:50 (20 minutes)

Presenter: TERUNUMA, Nobuhiro (KEK)

Session Classification: ATF2 Project meeting // Nanometer beams and stability